

# Modeling the Effect of Technology Trends on the Soft Error Rate of Combinational Logic

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## Abstract

*This paper examines the effect of technology scaling and microarchitectural trends on the rate of soft errors in CMOS memory and logic circuits. We describe and validate an end-to-end model that enables us to compute the soft error rates (SER) for existing and future microprocessor-style designs. The model captures the effects of two important masking phenomena, electrical masking and latching-window masking, which inhibit soft errors in combinational logic. We quantify the SER due to high-energy neutrons in SRAM cells, latches, and logic circuits for feature sizes from 600nm to 50nm and clock periods from 16 to 6 fan-out-of-4 inverter delays. Our model predicts that the SER per chip of logic circuits will increase nine orders of magnitude from 1992 to 2011 and at that point will be comparable to the SER per chip of unprotected memory elements. Our result emphasizes that computer system designers must address the risks of soft errors in logic circuits for future designs.*

## 1 Introduction

Two important trends driving microprocessor performance are scaling of device feature sizes and increasing pipeline depths. In this paper we explore how these trends affect the susceptibility of microprocessors to soft errors. Device scaling is the reduction in feature size and voltage levels of the transistors, which improves performance because smaller devices require less current to turn on or off, and thus can be operated at higher frequencies. Pipelining is a microarchitectural technique of dividing instruction processing into stages which can operate concurrently on different instructions. Pipelining improves performance by increasing instruction level parallelism (ILP). Five to eight stage pipelines are quite common, and some recent designs use twenty or more stages [11]. Such designs are commonly referred to as *superpipelined* designs.

Our study focuses on *soft errors*, which are also called transient faults or single-event upsets (SEUs). These are errors in processor execution that are due to electrical noise or external radiation rather than design or manufacturing defects. In particular, we study soft errors caused by high-energy neutrons resulting from cosmic rays colliding with particles in the atmosphere. The existence of cosmic ray radiation has been known for over 50 years, and the capacity for this radiation to create transient faults in semiconductor circuits has been studied since the early 1980s. As a result, most modern microprocessors already incorporate mechanisms for detecting soft errors. These mechanisms are typically focused on protecting memory elements, particularly caches, using error-correcting codes (ECC), parity, and other techniques. Two key reasons for this focus on memory elements are: 1) the techniques for protecting memory elements are well understood and relatively inexpensive in terms of the extra circuitry required, and 2) caches take up a large part, and in some cases a majority, of the chip area in modern microprocessors.

Past research has shown that combinational logic is much less susceptible to soft errors than memory elements [8, 19]. Three phenomena provide combinational logic a form of natural resistance to soft errors: 1) logical masking, 2) electrical masking, and 3) latching-window masking. We develop models for electrical masking and latching-window masking to determine how these are affected by device scaling and superpipelining. Then based on a composite model we estimate the effects of these technology trends on the soft error rate (SER) of combinational logic. Finally using an overall chip area model we compare the SER/chip of combinational logic with the expected trends in SER of memory elements.

The primary contribution of our work is an analysis of the trends in SER for SRAM cells, latches, and combinational logic. Our models predict that by 2011 the soft error rate in combinational logic will be comparable to that of unprotected memory elements. This result is signifi-

cant because current methods for protecting combinational logic have significant costs in terms of chip area, performance, and/or power consumption in comparison to protection mechanisms for memory elements.

The rest of this paper is organized as follows. Section 2 provides background on the nature of soft errors, and a method for estimating the soft error rate of memory circuits. Section 3 introduces our definition of soft errors in combinational logic, and examines the phenomena that can mask soft errors in combinational logic. Section 4 describes in detail our methodology for estimating the soft error rate in combinational logic. We present our results in Section 5. Section 6 discusses the implications of our analysis and simulations. Section 7 summarizes the related work, and Section 8 concludes the paper.

## 2 Background

### 2.1 Particles that cause soft errors

In the early 1980s, IBM conducted a series of experiments to measure the particle flux from cosmic rays [32], the rate of flow expressed as the number of particles of a particular energy per square centimeter per second. For our work, the most important aspect of these results is that particles of lower energy occur far more frequently than particles of higher energy. In particular, a one order of magnitude difference in energy can correspond to a two orders of magnitude larger flux for the lower energy particles. As CMOS device sizes decrease, they are more easily affected by these lower energy particles, potentially leading to a much higher rate of soft errors.

This paper investigates the soft error rate of combinational logic caused by atmospheric neutrons with energies greater than 1 mega-electron-volt (MeV). This form of radiation, the result of cosmic rays colliding with particles in the atmosphere, is known to be a significant source of soft errors in memory elements. We do not consider atmospheric neutrons with energy less than 1 MeV since we believe their much lower energies are less likely to result in soft errors in combinational logic. We also do not consider alpha particles, since this form of radiation comes almost entirely from impurities in packaging material, and thus can vary widely for processors within a particular technology generation. The contribution to the overall soft error rate from each of these radiation sources is additive, and thus each component can be studied independently.

### 2.2 Soft errors in memory circuits

High-energy neutrons that strike a sensitive region in a semiconductor device deposit a dense track of electron-hole pairs as they pass through a p-n junction. Some of the deposited charge will recombine to form a very short duration

pulse of current at the internal circuit node that was struck by the particle. When a particle strikes a sensitive region of an SRAM cell, the charge that accumulates could exceed the minimum charge that is needed to flip the value stored in the cell, resulting in a soft error. The smallest charge that results in a soft error is called the *critical charge* ( $Q_{CRIT}$ ) of the SRAM cell [7]. The rate at which soft errors occur is typically expressed in terms of *Failures In Time (FIT)*, which measures the number of failures per  $10^9$  hours of operation. A number of studies on soft errors in SRAMs have concluded that the SER for constant area SRAM arrays will increase as device sizes decrease [15, 24, 25], though researchers differ on the rate of this increase.

A method for estimating SER in CMOS SRAM circuits was recently developed by Hazucha & Svensson [10]. This model estimates SER due to atmospheric neutrons (neutrons with energies  $> 1$  MeV) for a range of submicron feature sizes. It is based on a verified empirical model for the 600nm technology, which is then scaled to other technology generations. The basic form of this model is:

$$SER \propto F \times A \times \exp\left(-\frac{Q_{CRIT}}{Q_S}\right) \quad (1)$$

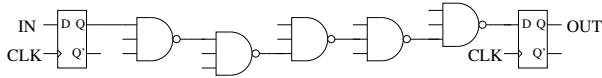
where

$F$	is the neutron flux with energy $> 1$ MeV, in particles/(cm <sup>2</sup> *s),
$A$	is the area of the circuit sensitive to particle strikes, in cm <sup>2</sup> ,
$Q_{CRIT}$	is the critical charge, in fC, and
$Q_S$	is the charge collection efficiency of the device, in fC

Two key parameters in this model are the critical charge ( $Q_{CRIT}$ ) of the SRAM cell and the charge collection efficiency ( $Q_S$ ) of the circuit.  $Q_{CRIT}$  depends on characteristics of the circuit, particularly the supply voltage and the effective capacitance of the drain nodes.  $Q_S$  is a measure of the magnitude of charge generated by a particle strike. These two parameters are essentially independent, but both decrease with decreasing feature size. From Equation 1 we see that changes in the value of  $Q_{CRIT}$  relative to  $Q_S$  will have a very large impact on the resulting SER. The SER is also proportional to the area of the sensitive region of the device, and therefore it decreases proportional to the square of the device size. Hazucha & Svensson used this model to evaluate the effect of device scaling on the SER of memory circuits. They concluded that SER-per-chip of SRAM circuits should increase at most linearly with decreasing feature size.

## 3 Soft Errors in Combinational Logic

A particle that strikes a p-n junction within a combinational logic circuit can alter the value produced by the cir-



**Figure 1. Simple model of a pipeline stage**

cuit. However, a transient change in the value of a logic circuit will not affect the results of a computation unless it is captured in a memory circuit. Therefore, we define a soft error in combinational logic as a transient error in the result of a logic circuit that is subsequently stored in a memory circuit of the processor.

A transient error in a logic circuit might not be captured in a memory circuit because it could be *masked* by one of the following three phenomena:

**Logical masking** occurs when a particle strikes a portion of the combinational logic that is blocked from affecting the output due to a subsequent gate whose result is completely determined by its other input values.

**Electrical masking** occurs when the pulse resulting from a particle strike is attenuated by subsequent logic gates due to the electrical properties of the gates to the point that it does not affect the result of the circuit.

**Latching-window masking** occurs when the pulse resulting from a particle strike reaches a latch, but not at the clock transition where the latch captures its input value.

These masking effects have been found to result in a significantly lower rate of soft errors in combinational logic compared to storage circuits in equivalent device technology [19]. However, these effects could diminish significantly as feature sizes decrease and the number of stages in the processor pipeline increases. Electrical masking could be reduced by device scaling because smaller transistors are faster and therefore may have less attenuation effect on a pulse. Also, deeper processor pipelines allow higher clock rates, meaning the latches in the processor will cycle more frequently, which may reduce latching-window masking.

We evaluate the effects of electrical and latching-window masking using the simple model for a processor pipeline stage illustrated in Figure 1. This model is just a one-wide chain of homogeneous gates terminating in a level-sensitive latch. For the results presented in this paper we use static NAND gates with a fan-out of 4. The number of gates in the chain is determined by the degree of pipelining in the microarchitecture, which we characterize by the number of fan-out-of-4 inverter (FO4) gates that can be placed between two latches in a single pipeline stage. The FO4 metric is technology independent and 1 FO4 roughly corresponds to 360 pico-seconds times the transistor's drawn gate length in microns [12]. In our model we use level-sensitive latches because their advantages in area and tolerance to clock load/skew make them attractive for super-pipelined designs.

## 4 Methodology

In most modern microprocessors, combinational logic and memory elements are constructed from the same basic devices – NMOS and PMOS transistors. Therefore, we can use techniques for estimating the SER in memory elements to assess soft errors in combinational logic. We will also use these techniques directly to compute the SER in memory elements for a range of device sizes, and compare the results to our estimates of SER for combinational logic.

Our methodology for estimating the soft error rate in combinational logic considers the effects of CMOS device scaling and the microarchitectural trend toward increasing depth of processor pipelines. We determine the soft error rate using analytical models for each stage of the pulse from its creation to the time it reaches the latch. Figure 2 shows the various stages the pulse passes through and the corresponding model used to determine the effect on the pulse at that stage. In the first stage the charge generated by the particle strike produces a current pulse, which is then converted into a voltage pulse after traveling through a gate in the logic chain. The electrical masking model simulates the degradation of the pulse as it travels through the gates of the logic circuit. Finally a model for the latching window determines the probability that the pulse is successfully latched. The remainder of this section describes each of these component models and how they are combined to obtain an estimate for the SER of combinational logic. Additional details on our methodology can be found in an extended version of this paper [30].

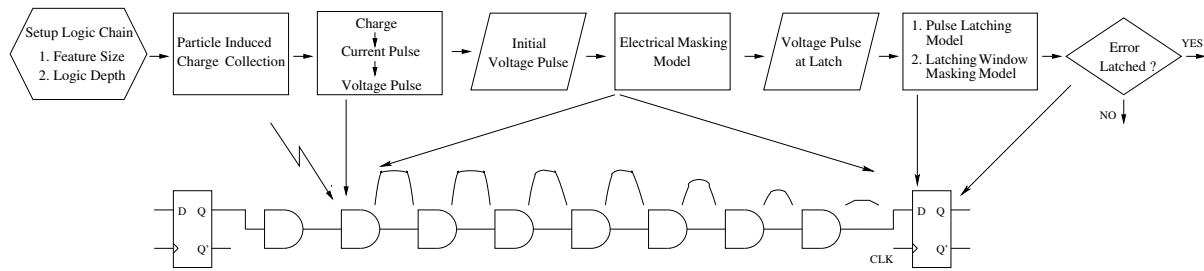
### 4.1 Device scaling model

We constructed a set of Spice Level 3 technology models corresponding to the technology generations from the Semiconductor Industry Association (SIA) 1999 technology roadmap [29]. Values for drawn gate length, supply voltage, and oxide thickness are taken directly from the roadmap. The remaining parameters were obtained using a scaling methodology developed by McFarland [21]. We adjusted McFarland's formula for threshold voltage slightly to scale better to technologies with very low supply voltages, but all other parameters are based on McFarland's model.

### 4.2 Charge to voltage pulse model

When a particle strikes a sensitive region of a circuit element it produces a current pulse with a rapid rise time, but a more gradual fall time. The shape of the pulse can be approximated by a one-parameter function [7] shown in Equation 2.

$$I(t) \propto \frac{Q}{T} \times \sqrt{\frac{t}{T}} \times \exp\left(-\frac{t}{T}\right) \quad (2)$$



**Figure 2. Process for determining the Soft Error Rate in a logic chain**

$Q$  refers to the amount of charge collected due to the particle strike. The parameter  $T$  is the time constant for the charge collection process and is a property of the CMOS process used for the device. If  $T$  is large it takes more time for the charge to recombine. If  $T$  is small, the charge recombines rapidly, generating a current pulse with a short duration. The time constant decreases as feature size decreases, and Hazucha & Svensson developed a method for scaling the time constant based on feature size [10]. The rapid rise of the current pulse is captured in the square root function and the gradual fall of the current pulse is produced by the negative exponential dependence.

The current pulse produced by a particle strike results in a voltage pulse at the output node of the device. We use a Spice simulation to determine the rise time, fall time and effective duration of this voltage pulse. These three values are the final result of this stage and become the input for the next phase, the electrical masking analytical model.

### 4.3 Electrical masking model

Electrical masking is the composition of two electrical effects that reduce the strength of a pulse as it passes through a logic gate. Circuit delays caused by the switching time of the transistors cause the rise and fall time of the pulse to increase. Also, the amplitude of a pulse with short duration may decrease since the gate may start to turn off before the output reaches its full amplitude. The combination of these two effects reduces the duration of a pulse, making it less likely to cause a soft error. The effect cascades from one gate to the next because at each gate the slope decreases and hence the amplitude also decreases.

We constructed a model for electrical masking by combining two existing models. We use the Horowitz rise and fall time model [13] to determine the rise and fall time of the output pulse, and the Logical Delay Degradation Effect Model [3] to determine the amplitude, and hence the duration, of the output pulse.

**Horowitz rise and fall time model:** The Horowitz model calculates the rise and fall time of the output pulse based on the the input rise and fall time, the CMOS model parameters, and the gate switching voltages. The gate switching voltages are determined using an iterative bisection method.

This procedure adjusts the switching voltages until the rise and fall times predicted by the model are within 15% of values obtained from Spice simulations.

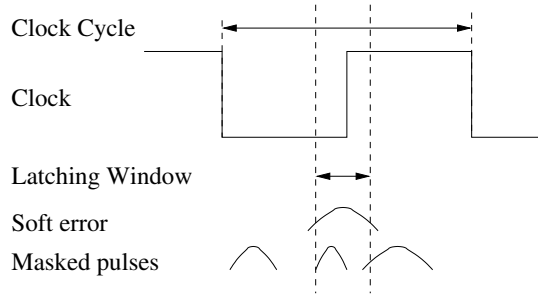
**Delay degradation model:** Delay degradation occurs when an input transition occurs before the gate has completely switched from its previous transition. When this occurs, the gate switches in the opposite direction before reaching the peak amplitude of the input pulse, thus degrading the amplitude of the output pulse. We use the “Delay Degradation Model” proposed and validated by Bellido-Diaz *et al.* [3] to determine how a voltage pulse degrades as it passes through a logic gate. This model determines the amplitude of the output pulse based on the time between the output transition and the next input transition, and the time needed for the gate to switch fully.

### 4.4 Pulse latching model

Recall that our definition of a soft error in combinational logic requires an error pulse to be captured in a memory circuit. Therefore, in our model a soft error occurs when the error pulse is stored into the level-sensitive latch at the end of a logic chain. We only consider a value to be stored in the latch if it is present and stable when the latch closes, since this value is passed to the next pipeline stage.

When a voltage pulse reaches the input of a latch, we use a Spice simulation to determine if it has sufficient amplitude and duration to be captured by the latch. By keeping the rise and fall time constant, but varying the duration, the simulation determines the minimum duration (measured at the threshold voltage) pulse that could be latched. If the duration of the pulse at the latch input exceeds this minimum duration, it has the potential to cause a soft error.

This method determines if a particle-induced pulse in an otherwise stable, correct input signal is strong enough to be latched. It is also possible that a particle-induced pulse could delay the correct input signal from arriving at the latch input in time to be latched, thus causing an error. This type of error is referred to as a *delay fault*. Due to the complexity of modeling these faults, we have chosen to exclude them from our study. Bernstein found that delay faults are negligible in current technologies due to the common design practice of incorporating a 5%-10% safety margin into the



**Figure 3. Latching Window Masking**

clock cycle [4]. However, such faults could become much more common as clock frequency increases and safety margins are squeezed to increase performance.

#### 4.5 Latching-window masking model

A latch is only vulnerable to a soft error during a small window around its closing clock edge. The size of this *latching window* is simply the minimum duration pulse that can be latched, which depends on the pulse rise and fall time. A pulse that is present at the latch input throughout the entire latching window will be latched and causes a soft error. If a pulse partially overlaps the latching window, there is the possibility that it may also cause a soft error, since it could prevent the data from satisfying the latch setup and hold time requirements. We believe this is a secondary effect and therefore we have ignored it in our model. This simplification results in a more conservative estimate of SER. Figure 3 illustrates our model of latching window masking. Only a pulse that completely overlaps the latching window results in a soft error. If the pulse either arrives after the latching window has opened, terminates before the latching window closes, or does not have sufficient duration to cover the whole window, we assume that the pulse will be masked.

Let  $d$  represent the duration of the pulse on arrival at the latch input at time  $t$ . The pulse arrival time  $t$  can occur at any point in the clock cycle with equal probability. Let  $w$  represent the size of the latching window for this pulse, and let  $c$  represent the clock cycle time. If a latching window for the latch starts after time  $t$  and ends before time  $t + d$ , the pulse is present at the latch input throughout the entire latching window and results in a soft error. Otherwise the pulse is masked and no soft error occurs.

We can determine the probability that the pulse causes a soft error by computing the probability that a randomly placed interval of length  $d$  overlaps a fixed interval of length  $w$  within an overall interval of length  $c$ . This probability is given in by the following equation:

$$\Pr\{\text{soft error}\} = \begin{cases} 0 & \text{if } d < w \\ \frac{d-w}{c} & \text{if } w \leq d \leq c + w \\ 1 & \text{if } d > c + w \end{cases}$$

Note that when  $d < w$ , the probability of a soft error is zero, but this is not an effect of latching window masking, since the pulse does not have sufficient duration to be latched. On the other hand, when the pulse duration exceeds  $c + w$ , it is assured to overlap at least one full latching window of size  $w$  and hence has probability 1 of causing a soft error. Note that a smaller pulse could partially overlap the latching windows in two consecutive clock cycles without fully containing either one. Since pulse arrival times are distributed uniformly at random over the clock cycle, the probability of an error for a pulse with any intermediate duration is a simple linear function between these two endpoints.

#### 4.6 Estimating SER for combinational logic

We assume that the probability of concurrent particle strikes in a single logic chain is negligible, and thus the SER for the circuit is simply the sum of the SER's for a particle strike at each gate in the logic chain. To compute the SER contribution for a given gate in the logic chain, we simulate a particle strike to the drain of the gate using our charge to voltage pulse model. Then we apply our electrical masking model to determine the characteristics of the voltage pulse when it reaches the latch input. We use the pulse-latching model to determine if the pulse that reaches the latch input has sufficient amplitude and duration to cause a soft error. As in memory circuits, the smallest charge that can generate a pulse that results in a soft error is the critical charge ( $Q_{CRIT}$ ) for the circuit. For combinational logic, we are also interested in  $Q_{CMAX}$ , the smallest charge that has probability of 1 of being latched according to our latching-window masking model. Charge values between  $Q_{CRIT}$  and  $Q_{CMAX}$  have the potential to be masked by latching-window masking, but charge values of  $Q_{CMAX}$  or greater always result in a soft error.

To complete the calculation of SER for a given gate in the logic chain, we divide the charge values between  $Q_{CRIT}$  and  $Q_{CMAX}$  into  $m$  equal-size intervals. We used  $m = 20$  for the results presented in this paper; using separate experiments we validated that using a higher granularity has only a marginal effect on the resulting SER estimates. We compute the SER corresponding to each interval using the model of Hazucha & Svensson. Since the Hazucha & Svensson model gives a cumulative SER value, we compute the SER for an interval by subtracting the SER of the right endpoint of the interval from that of the left. The SER for the interval is then weighted by the probability that a soft error occurs as given by our latching-window masking model. The contribution to SER for the gate is then the sum of the weighted SER's for each interval plus the SER for  $Q_{CMAX}$ . This calculation is summarized with the following formula:

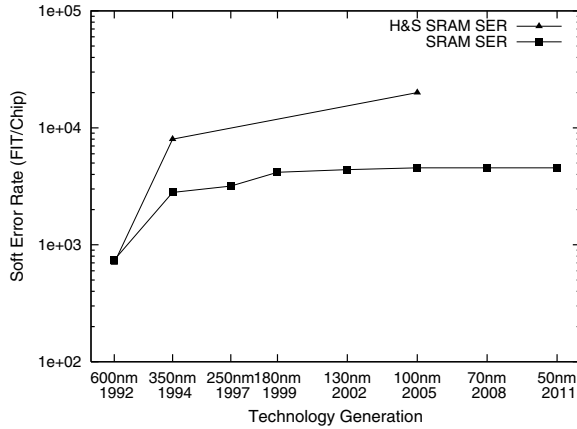


Figure 4. SER of a constant area SRAM array

$$SER = SER(Q_{CMAX}) + \sum_{i=1}^m \Pr\{L_i\} (SER(L_i) - SER(R_i))$$

where  $SER(Q)$  denotes the SER value for charge  $Q$  obtained from Hazucha & Svensson's model,  $L_i$  and  $R_i$  are the left and right endpoints of interval  $i$ , and  $\Pr\{L_i\}$  is the probability that charge  $L_i$  causes a soft error (is not latching-window masked).

## 5 Results

### 5.1 Memory circuits

To validate our technology models, we estimated the SER of a constant area SRAM array using Hazucha & Svensson's model and our CMOS technology parameters. We used hspice simulations to determine  $Q_{CRIT}$  values for each technology. We simulated a current pulse at the drain of one node of the SRAM cell and sampled the cell later to see if the value had changed. Figure 4 presents our results, along with the results of a similar experiment reported by Hazucha and Svensson [10]. Our results show good correlation with those of Hazucha and Svensson; both results show the same basic trend, and the absolute error is less than one order of magnitude for all technologies, which can be attributed to differences in CMOS parameters. The graph shows that the SER increases slightly from 600nm to 50nm, with nearly all the increase occurring by the 180nm technology generation. There are four basic factors that combine to produce this trend. The drain area of each transistor, which is the region sensitive to particle strikes, decreases quadratically as feature size decreases, but since the SRAM array occupies a constant area, the number of bits increases quadratically and offsets this effect. Critical charge also decreases significantly with decreasing feature size, primarily due to lower supply voltage levels, but charge accumulation

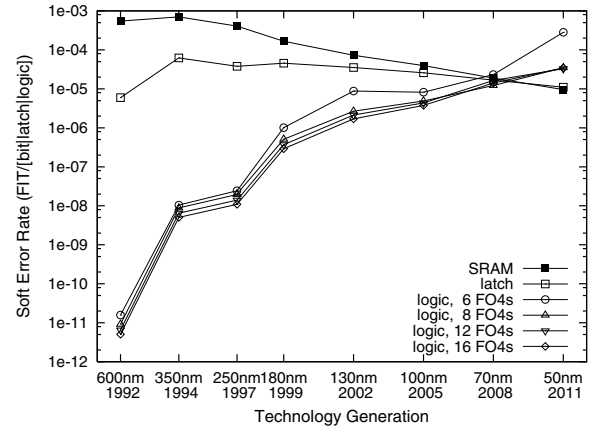


Figure 5. SER of individual circuits

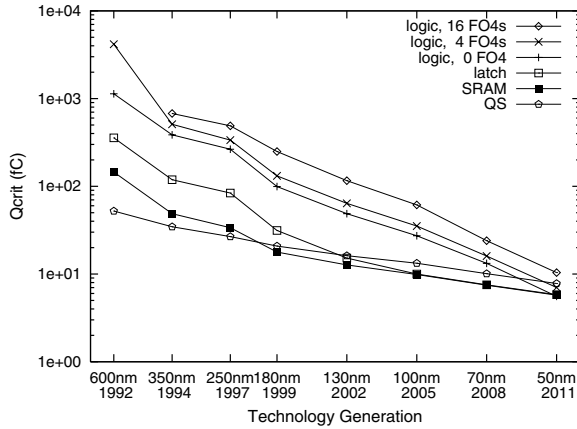
in the transistor also decreases and effectively offsets the reduction in critical charge.

### 5.2 Individual circuits

The circuits of a modern microprocessor fall into three basic classes: SRAM cells, latches, and combinational logic. We estimated the SER for an individual SRAM cell, latch, and logic chain using methodology described in Section 4. Figure 5 shows the predicted SER by technology and pipeline depths. The x-axis plots the CMOS technology generation, arranged by actual or expected date of adoption, and the y-axis plots the SER for each element on a log scale. The SER of a single SRAM cell declines gradually with decreasing device size, while the SER of a latch stays relatively constant. The SER for a single logic chain shows the most significant change – increasing over five orders of magnitude from 600nm to 50nm. The effect of superpipelining is illustrated by the increasing SER for logic circuits at higher pipeline depths (smaller clock period in FO4 delays) within each technology generation.

The primary cause of the significant increase in the SER of logic circuits is the reduction in  $Q_{CRIT}$  of logic circuits with decreased feature size. Recall from Equation 1 that the ratio  $-Q_{CRIT}/Q_S$  appears as an exponent in the empirical model for SER. When this ratio is large, this factor dominates the SER expression, but its influence decreases rapidly as the value of  $Q_{CRIT}$  approaches  $Q_S$ . Figure 6 plots  $Q_{CRIT}$  for SRAM cells, latches, and logic circuits, along with  $Q_S$ , the charge collection efficiency, by technology generation. For combinational logic, the graph shows  $Q_{CRIT}$  values for a particle strike 0, 4, and 16 FO4 gate-delays from the latch. Note that the y-axis of the graph is log-scale.

**SRAMs and Latches:** The  $Q_{CRIT}$  of SRAM cells decreases steadily with feature size, but is within a small constant factor of  $Q_S$  for all feature sizes. As a result, the primary effect of device scaling on the SER of a single SRAM



**Figure 6. Critical charge for SRAM/latch/logic**

cell is the reduction in sensitive area, leading to gradual downward trend shown in Figure 5. The  $Q_{CRIT}/Q_S$  ratio for latches is larger than for SRAMs at large feature sizes, but  $Q_{CRIT}$  of latches decreases more rapidly than SRAMs with decreasing feature size, and by 130nm has converged to almost the same value as SRAMs. This explains the relatively small change in the SER for a single latch shown in Figure 5. Device scaling in memory elements affects the critical charge and charge collection efficiency almost equally because smaller transistors are more sensitive to a particle strike but have very little sensitive volume for charge collection.

**Combinational Logic:** Figure 6 shows that the  $Q_{CRIT}$  of logic circuits decreases more rapidly with feature size than the  $Q_{CRIT}$  of memory elements. Since the y-axis of this graph is log scale, the actual decline is exponentially greater across this range of feature sizes. This steep reduction in  $Q_{CRIT}$  is primarily due to quadratic decrease in node capacitance with feature size. Logic transistors are typically wider than transistors used in memory circuits, where density is important, and thus this effect is more pronounced in logic circuits.

Figure 6 also illustrates the effect of electrical masking on the SER of logic circuits. For all feature sizes below 600nm, the  $Q_{CRIT}$  for 16 FO4 logic gates is consistently about twice that of the 0 FO4 circuit, and this difference is the result of degradation of the error pulse as it passes through the 16 FO4 gates. Contrary to our expectations, our results do not show any reduction in this effect with decreasing feature size. We conclude that the primary effect of electrical masking is to screen out marginal pulses; the degradation effect on pulses with sufficient strength to be latched is minimal.

We also performed experiments to determine the effect of technology trends on latching-window masking. The results show a significant decrease in latching-window mask-

Pipeline depth	SRAM bits	Latches	Logic gates
16 FO4s	1994 K (78.8%)	32 K ( 1.2%)	507 K (20.0%)
12 FO4s	1984 K (78.3%)	42 K ( 1.7%)	507 K (20.0%)
8 FO4s	1963 K (77.5%)	63 K ( 2.5%)	507 K (20.0%)
6 FO4s	1942 K (76.7%)	84 K ( 3.3%)	507 K (20.0%)

**Table 1. Chip Model for 350nm device size**

ing by feature size and consistently lower latching-window masking for higher degrees of pipelining. Detailed results of these experiments are available in our technical report [30].

### 5.3 Processor SER

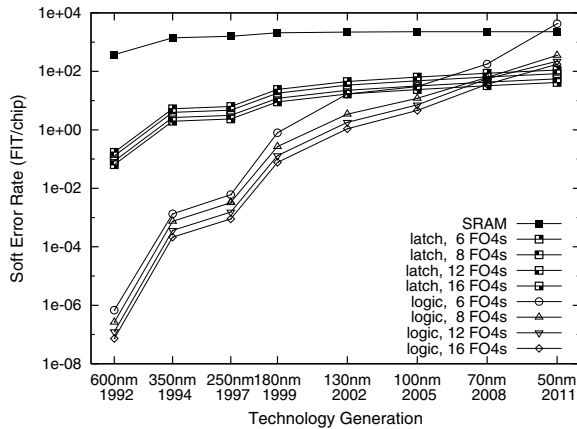
Now we determine how soft errors in SRAM cells, latches, and logic circuits contribute to the SER of the entire processor chip for future microprocessor technologies. To estimate the SER of the entire chip we have developed a chip model that describes the transistor decomposition into logic, SRAMs and latches. From the chip model we determine the total number of SRAM bits, latches and logic chains and then scale the per unit SER of each circuit by their number on the chip to obtain the SER/chip.

**Chip Model:** We used the Alpha 21264 microprocessor as the basis for constructing our chip model. The Alpha 21264 was designed for a 350nm process and has 15.2 million transistors on the die [18]. Based on a detailed area analysis of die photos of the Alpha 21264 [17], we concluded that approximately 20% of transistors are in logic circuits and the remaining 80% are in storage elements in the form of latches, caches, branch predictors, and other memory structures. Our chip model applies this basic allocation to all feature sizes. The total number of transistors per chip is scaled quadratically from the baseline Alpha 21264 based on feature size. The allocation of memory element transistors to SRAM cells and latches depends on the number of latches required by the processor pipeline, which depends on pipeline depth. We allocate one latch for each logic chain, where the number of logic chains is given by Equation 3.

$$\text{logic\_chains} = \frac{\text{logic\_transistors}}{\text{gates\_per\_logic\_chain} \times \text{transistors\_per\_gate}} \quad (3)$$

The remaining memory element transistors are allocated to SRAM cells. Table 1 illustrates how our model allocates transistors to SRAM bits, latches, and logic gates in the 350nm feature size for four pipeline depths.

**Results:** Using the SER of individual elements shown in the previous section and our chip model, we computed the SER/chip for each class of components for each technology generation and pipeline depth of our study. The results are presented in Figure 7. As discussed above, SER/chip



**Figure 7. SER/chip for SRAM/latches/logic**

of SRAM shows little increase as feature size decreases. To simplify the graph we only plot SRAM data for one pipeline depth. Pipeline depth has no noticeable effect on the SRAM SER/chip, since the percentage of chip area allocated to SRAM changes very little. SER/chip in latches increases only slightly for all pipeline depths, a combined effect of the relatively constant SER/latch and the increasing number of latches at smaller feature sizes. SER/chip of latches increases for deeper pipelines, due solely to the greater number of latches required for deeper pipeline microarchitectures.

SER/chip in combinational logic increases dramatically from 600nm to 50nm, from  $10^{-7}$  to approximately  $10^2$ , or nine orders of magnitude. This is simply the composition of a  $10^6$  increase in SER per individual logic chain and more than 100 times increase in logic chains per chip. At 50nm with 6 FO4 pipeline, the SER per chip of logic exceeds that of latches, and is within two orders of magnitude of the SER per chip of unprotected memory elements. Mainstream microprocessors from Intel [14] and other vendors [17] have employed ECC to reduce SER of SRAM caches at feature sizes of up to 350nm. For processors that use ECC to protect a large portion of the memory elements on the chip, logic will quickly become the dominant source of soft errors.

## 6 Discussion

The primary focus of our study has been to establish the basic trend in SER of combinational logic and the major influences on this trend. Our model considers the effects of device scaling and superpipelining trends, and the corresponding effects on electrical and latching window masking. This section discusses other factors that may also have some influence on SER of combinational logic, but are not considered in our model to simplify the model construction and analysis.

**Circuit Implementations:** We restricted our analysis to static combinational logic circuits and level-sensitive latches. Modern microprocessors frequently employ a diverse set of circuit styles, including dynamic logic, and latched domino logic, and a variety of latches, including edge-triggered flip flops, with different combinations of performance, power, area, and noise margin characteristics. We believe our model could be extended to include these additional circuit styles and latch designs.

The use of dynamic logic could substantially increase the SER, since each gate has built-in state that can reinforce an error pulse as it travels through a logic chain. Designs that employ edge-triggered flip flops should have lower SER, because the critical charge for these latches is generally larger than for level-sensitive latches. These points illustrate the importance of design choices on the overall SER.

**Logical Masking:** Logical masking is another masking effect that inhibits soft errors in combinational logic and could have a significant effect on the SER. Since our model places every logic gate on an active path to a latch, we do not account for the effect of logical masking. Incorporating logical masking would likely increase the complexity of the model dramatically, since the model would need to consider actual circuits and associated inputs. Massengill *et al.* developed a specialized VHDL simulator that could analyze soft faults in an actual circuit and model the effects of logical masking [20]. They found that effect of logical masking on SER depends heavily on circuit inputs.

Effects similar to logical masking can also occur in memory elements. For example, if a soft error occurs in a memory element that holds dead data – data that will not be used again – it is in some sense logically masked. Another example is a soft error in a memory structure such as a branch predictor, which may lead to reduced performance but not produce incorrect results. Due to the difficulty in modeling these effects, we have chosen to exclude all forms of logical masking in memory elements or logic from our model. However, it seems unlikely that logical masking will be significantly affected by the technology trends we consider in this study.

**Alpha Particles:** Our study only considers soft errors resulting from high-energy neutrons. Another important source of soft errors in microprocessors is alpha particles that originate from radioactive decay of impurities in chip and packaging materials. For circuits with  $Q_{CRIT}$  in the range of 10-40 fC, the alpha particle SER becomes comparable to that of neutron SER [9]. In our experiments, this range corresponds to SRAM cells and latches in 180nm and later technologies and logic circuits in 50nm and later technologies. Our model could be adapted to estimate the SER due to alpha particle radiation.



## 7 Related Work

Although this is the first paper to model the effect of both technology scaling and superpipelining on the soft error rate of combinational logic, previous experimental work has been done to estimate the soft error rate of storage and combinational logic in existing technologies [25, 6, 16, 19, 24].

Another method for estimating the neutron-induced SER uses the Modified Burst Generation Rate model [31]. This method uses nuclear theory to calculate the collected charge resulting from a particle strike. IBM developed the SEMM (Soft-Error Monte Carlo Modeling) program to determine whether chip designs meet SER specifications [23]. The program calculates the SER of semiconductor chips due to ionizing radiation based on detailed layout, process information and circuit ( $Q_{CRIT}$ ) values.

Some work has also been done to estimate the SER in combinational logic. Liden *et al.* compared the soft error rate due to direct particle strikes in latches with the soft error rate from error pulses propagating through the logic gates [19]. They considered a circuit implemented in 1000nm technology clocked at 5MHz. They conclude that the errors are predominantly due to direct strikes to latches and only 2% of the total observed errors are from the logic chain. We have shown how technology trends will lead to a significant increase in the SER at low feature sizes and high clock rates. Baze *et al.* studied electrical masking in a chain of inverters and concluded that for pulses that successfully get latched electrical masking does not have any significant effect on SER [2]. They also allude to various parameters such as the chip model and the clock rate as factors that might affect the impact of this effect on the overall SER. Our results show that electrical masking does have a significant effect on the SER, and this effect is not diminishing with decreased feature size. Buchner *et al.* investigated latching window masking in combinational and sequential logic [5]. They concluded that while the SER of sequential logic is independent of frequency, combinational logic SER increases linearly with clock rate. Our results confirm that the trend of increasing clock rate due to increased processor pipelining significantly increases the SER of logic circuits.

Seifert *et al.* used experiments and simulation to determine the trend of soft error rate in the family of Alpha processors [28]. They conclude that the alpha particle susceptibility of both logic and memory circuits has decreased over the last few process generations. Our study shows an increasing susceptibility to neutron-induced soft errors, particularly in logic circuits, due to device scaling and greater neutron flux at lower energies [32]. They also found that the errors in combinational logic are predominantly due to direct strikes to pipeline latches, rather than error propagation in logic. Our simulations agree with this result at current feature sizes, but predict that SER of logic will ap-

proach SER of latches as feature sizes decrease. They also concluded that for a given feature size, clock rate has little influence on SER. The results we present in Figure 7 are consistent with this conclusion.

## 8 Conclusion

We have presented an analysis of how two key trends in microprocessor technology, device scaling and superpipelining, will affect the susceptibility of microprocessor circuits to soft errors. The primary impact of device scaling is that the on-currents of devices decrease and circuit delay decreases. As a result, particles of lower energy, which are far more plentiful, can generate sufficient charge to cause a soft error. Using a combination of simulations and analytical models, we demonstrated that this results in a much higher SER in microprocessor logic circuits as feature size decreases. We also demonstrate that higher clock rates used in superpipelined designs lead to an increase in the SER of logic circuits in all technology generations.

The primary cause of the significant increase in the SER of logic circuits is the reduction in critical charge of logic circuits with decreased feature size. Our analysis also illustrates the effect of technology trends on electrical and latching-window masking, which provide combinational logic with a form of natural protection against soft errors. We found that electrical masking has a significant effect on the SER of logic circuits in all technology generations, and this effect is not diminishing with feature size. The effect of latching-window masking is also important but is reduced by both decreasing feature size and increased clock rate of future technology generations. We conclude that current technology trends will lead to a substantially more rapid increase in the soft error rate in combinational logic than in storage elements. The implication of this result is that further research is required into methods for protecting combinational logic from soft errors.

Recently, a number of schemes have been proposed to detect or recover from transient errors in processor computations. All these techniques are either based on space redundancy (e.g. [1]) or time redundancy (e.g. [22, 26, 27]). We believe that techniques such as these combined with circuit and process innovations will be required to enable future construction of reliable high performance systems. Our work is significant because it provides a context for evaluating these various techniques on their effectiveness at reducing soft errors in combinational logic.

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